COPRA® RF-ICP-PVD-Assist Solutions

COPRA Plasma Sources Ensure sustainability of your Plasma Assisted Coating Productions

The COPRA LS-Source is an ICP Plasmasource which perfectly suites to existing batch coaters. The design of the source dimensions could be fully customized making it a perfect allround solution for both existing and future new industrial coaters.

"COPRA" Sputter Solution

Versatile Coating Concept enabling different coating solutions as:

- Plasma Assisted Magnetron Sputtering two step high deposition rate process for low loss optical filter, and high end decorative market applications
- PVD PECVD coating solution for high rate DLC applications

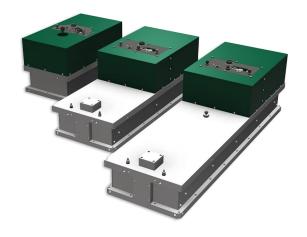


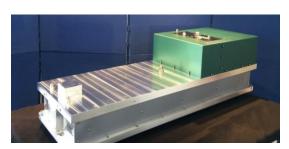
The COPRA plasma source transforms the reactively sputtered thin oxide layers into stoichiometric layers thus providing also highly efficient plasma cleaning, etching and preconditioning of the substrate surfaces. The high dissociation degree of the gas provided by the source technology is not increasing the process temperature thus enabling also temperature sensible processes.

The thin reactively sputtered layers carrying a controlled deficit of oxygen are successively oxidized by the COPRA Source with reactive oxygen. Any other reactive gases are also possible. The COPRA Sources are optimized to achieve higher throughput sputter rates through their excellent and fast oxidation properties for high industrial Needs.

Advantages by using the COPRA

- Excellent homogeneous distribution of the ion current density
- lon energy and lon current density are independently settable thus providing high process scalability for the desired substrate dimension
- Works with all gas types and reaches dissociation degrees of up to 90% and plasma densities >1x10¹² cm⁻³
- Sources can be customized in nearly every dimension in order to perfectly fit on exisiting machines
- No adjustment in pressure range is required—COPRA can also work in normal sputter pressure ranges
- Reproducibilty of process characteristics









CCR Technology

| LS Series | LS358x156-GR | LS670x202-GRPE | LS950x201-GRPE | LS1100x201-GRPE | LS1300x201-GRPE |
|---------------------------------------|---|---|---------------------------------|------------------------|------------------------|
| | | | | 12 | |
| Plasma Opening | 358x156 mm | 670x200 mm | 950x200 mm | 1100x200 mm | 1300x200 mm |
| Pressure Range | 2x10 ⁻⁴ to 1x10 ⁻² mbar | 5x10 ⁻⁴ to 1x10 ⁻² mbar | $3x10^{-4}$ to $1x10^{-2}$ mbar | 3x10-4 to 1x10-2 mbar | 3x10-4 to 1x10-2 mbar |
| RF-Power (max.) | 5 kW | 5 kW | 6 kW | 6 kW | 6 kW |
| Substrate width (dynamic) | 300 mm | 600 mm | 850 mm | 1000 mm | 1200 mm |
| Plasma | neutral beam | neutral beam | neutral beam | neutral beam | neutral beam |
| Frequency | 13,56 MHz | 13,56 MHz | 13,56 MHz | 13,56 MHz | 13,56 MHz |
| Body | AL | AL | AL | AL | AL |
| Process gas | almost any | almost any | almost any | almost any | almost any |
| Operation pure O2 | YES | YES | YES | YES | YES |
| Matching | via remote control CRC | via remote control CRC | via remote control CRC | via remote control CRC | via remote control CRC |
| Integrated Matchbox | YES | YES | YES | YES | YES |
| *pressure, power & distance dependent | | | | | |



Get in touch!

Should you have any questions regarding our products please feel free to contact us directly. We are pleased to receive your specific request and find an adequate solution which perfectly fits to your needs.

CCR Headquarter/Europe Camp-Spich-Strasse 3a

53842 Troisdorf Germany

T: +49(0)2241-93215-100 F: +49(0)2241-93215-200 contact(at)ccrtechnology.de www.ccrtechnology.de

France

OMICRON Technologies 2 rue Denis Papin Zone des Ruires 38320 EYBENS – FRANCE

T: +33 (0) 476 99 22 60 contact(at)omicron-technologies.com www.omicron-technologies.com

Australia & New Zealand

AVT Services Pty. Ltd. -Sydney 16/35 Foundry Road

Seven Hills, NSW 2147 - Australia

T: (02) 9674 6711 Nsw(at)avtservices.com.au www.avtservices.com.au

China

Shanghai Triplewins Vacuum Technology Co., Ltd 7th Floor, Yanfa Building, Henglu Industrial Zone, 166 Mindong Road, Shanghai, China

T: +86 21 6106 2148 sales(at)www-vacuum.com www.www-vacuum.com

USA - Northeast

IES Technical Sales 250 North Street, Unit A-9, Danvers, MA 01923-1206

T: +1 978 777 2900x218 Sean.stull(at)iestechsales.com www.iestechsales.com

USA - Westcoast (CA,WA,OR,ID)

Universal Vacuum Technology LLC. 7172 Regional Street, Suite 230

Dublin, CA 94568, USA

T: +1 510 583 5624 Les(at)universalvacuumtech.com www.universalvacuumtech.com

Taiwan

Junsun Tech. CO., LTD 7F No.659, Chung-Cheng Rd., Hsin-Chuang Dist., New Taipei City 24257, Taiwan, R.O.C

T: +886-2-2908-1350#20 junsun(at)junsun.com.tw www.junsun.com.tw

South Korea

JYT JY Technology SK Ventinum 104–801, 166 Gosan-ro Gunpo-si, Gyeonggi-do, Korea(15850)

T: +82 31 427 2292 sales(at)jytech.net www.jytech.net

UK & Ireland

Scanwel Ltd.
The Old School, Llandderfel, Bala

Gwynedd, LL237HW

T: +44 (0) 1678 530 281 Info(at)scanwel.co.uk www.scanwel.co.uk